



4" Stack BULLKID-DM Kick-off meeting

LNGS - 19/03/24

DANIELE PASCIUTO on behalf of the group

4" Wafer

Technical details:

OD - 100 mm

Thickness – 5 mm

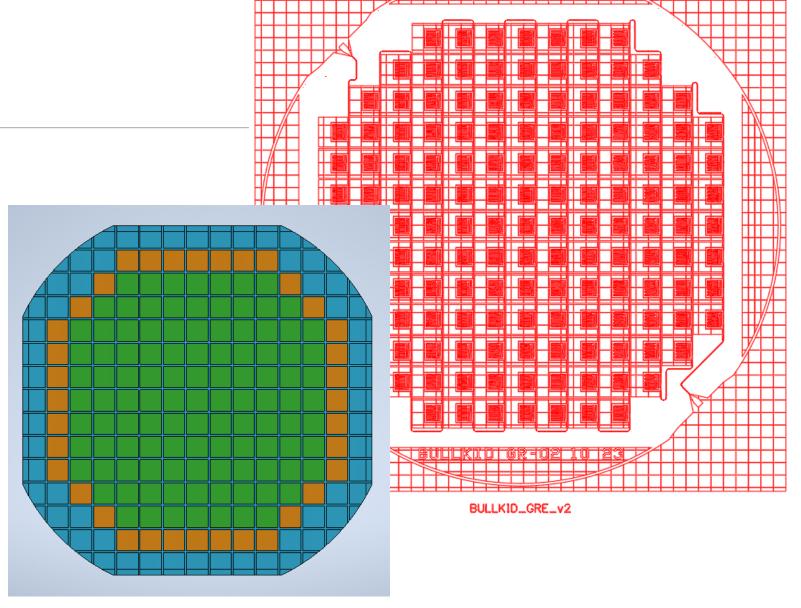
Active Voxels – 145 Units

- 109 fiducialized
- 36 external veto

Voxel area – 5.5 mm x 5.5 mm

Groove size – 0.5 mm x 4.5 mm

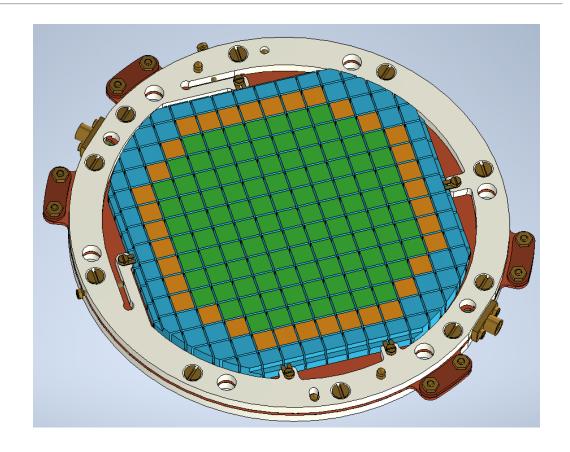
Common silicon common layer – 0.5 mm



Single module prototype

Main characteristics:

- Minimize materials with impurities (e.g. Cu)
- Optimize thermal contact between the holder and the silicon
- Referable and reproducible structure
- Symmetrical structure to avoid thermal distortion
- Stackable
- Optimizing cost
 - Minimizing waste
 - Production with INFN machining technologies



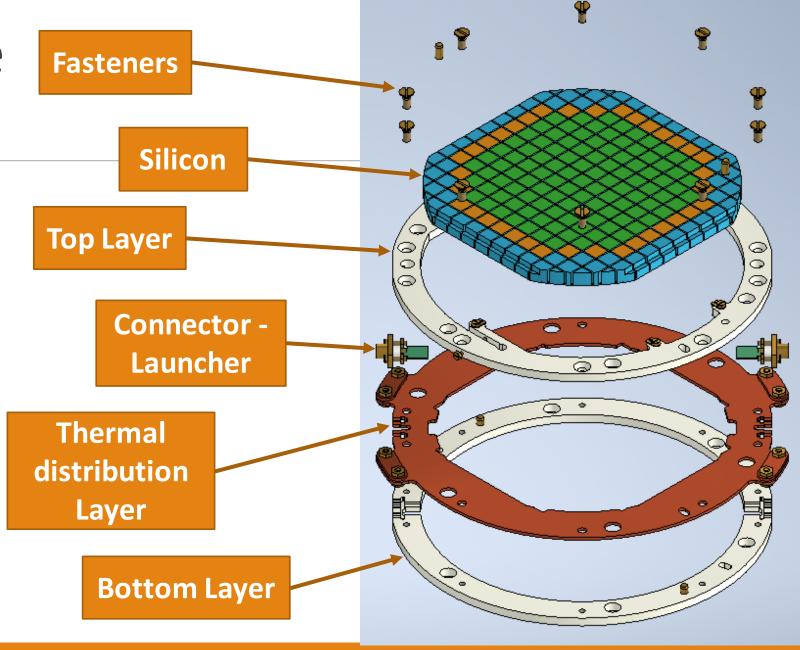
Single module prototype

Constraints:

- Vacuum 10-9 mbar
- Temperature 0.2K
- Low radioactive background
- Good mechanical and vibrational stability
- Easiness of mounting and handling

Materials allowed:

- Copper OFHC
- PTFE



Thermal distribution Layer

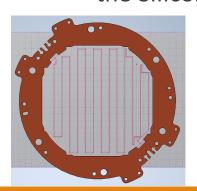
1 mm thick layer of OFHC copper

- Low mass structure
- Vacuum and radiation compatible

Machined with EDM

- No mechanical distortion
- High precision

Maximize thermal contact with the Silicon wafer



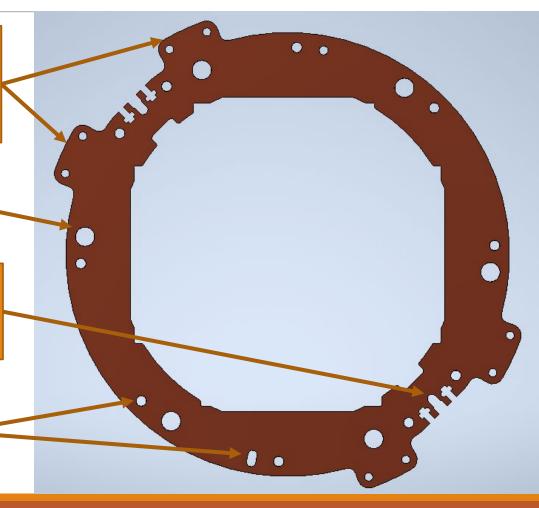
No interference with photolithography

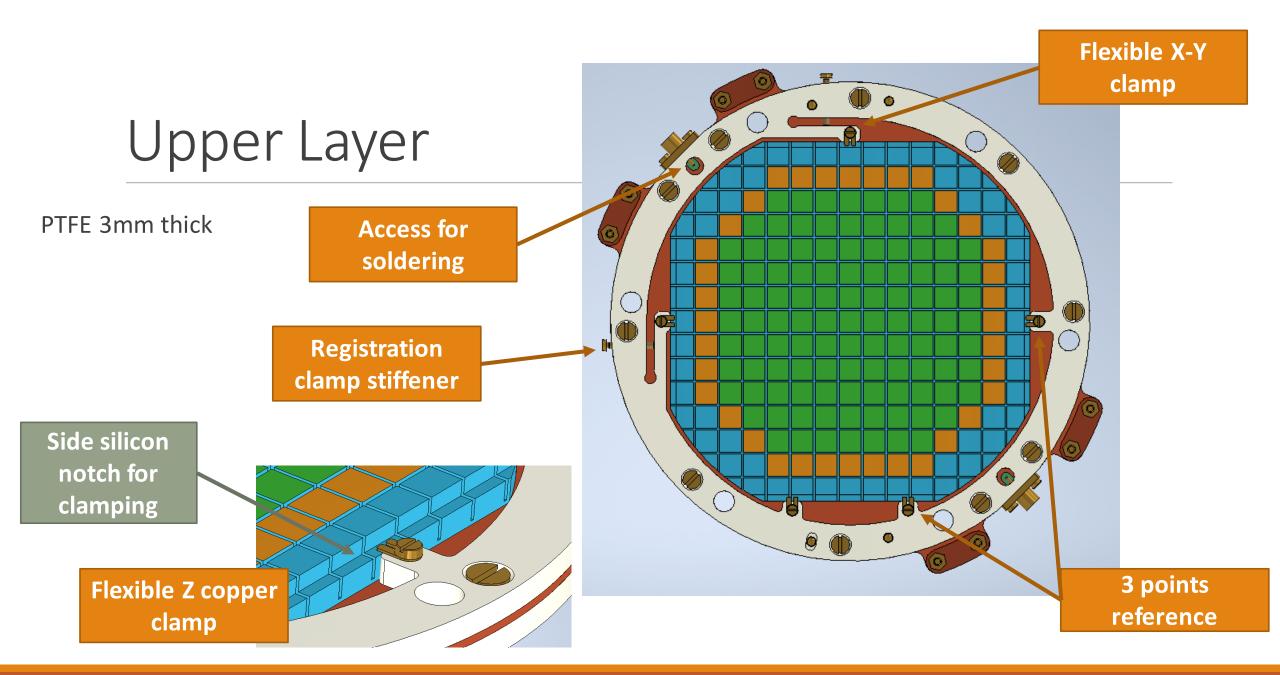
Thermal contacts for daisy-chain cooling

Hole for stack mounting

Shape for nut and launcher insertion

Hole for referencing and fastening



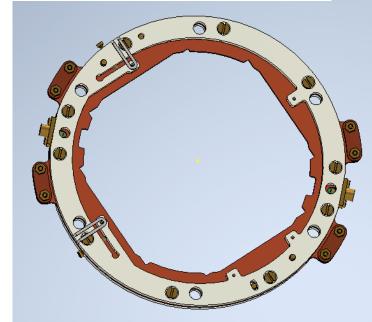


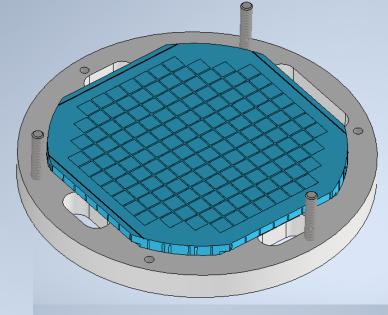
Module assembling

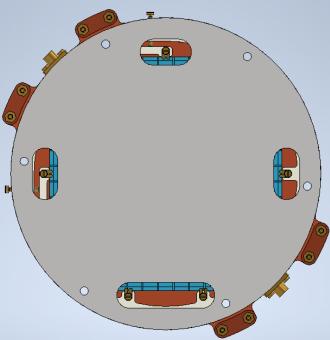
Support template for mounting with reference surfaces for wafer placement

Inserting preassembled structure with clamps to keep wafer fixture clamps open

Once the wafer has been secured with fasteners, mounting Z-clamps using the dedicated support windows







3-Module stack

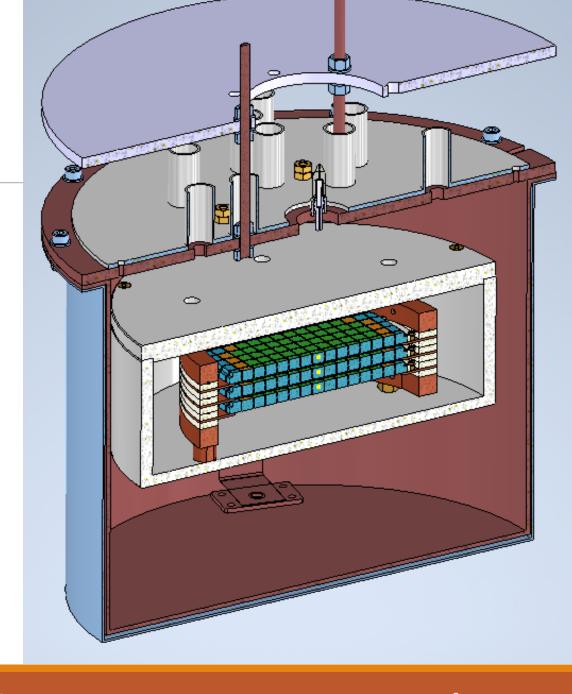
Pure aluminum (1000 series) vessel for shielding

Upper and Lower copper rings

- Stiffer structure for vibrations
- Thermal distributors for cooling

Copper rods for thermal contact with cold plated (missing in the drawing)

Feedthroughs for fibers in the aluminum lid (missing in the drawing) for optical calibration



Ongoing

Thermomechanical FEM analysis

3D Printed Prototype for handling and mounting procedures

Manufacturing validation at INFN machine shop

Substituting MCX connectors with clamped Cables



Thanks for your attention

